

**Notice of References Cited**

Application/Control No.

10/563,274

Applicant(s)/Patent Under  
Reexamination  
SHIONO ET AL.

Examiner

Kim-Kwok CHU

Art Unit

2627

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,256,283	07-2001	Fukakusa et al.	369/112.01
*	B	US-6,243,326	06-2001	Sumi et al.	369/13.29
*	C	US-5,602,825	02-1997	Sugaya et al.	369/275.4
*	D	US-5,406,545	04-1995	Kadowaki, Shin-ichi	369/275.3
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.